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CONFIRMATION NO. 8104

<b>SERIAL NUMBER</b> 10/645,529	<b>FILING OR 371(c) DATE</b> 08/22/2003 <b>RULE</b>	<b>CLASS</b> 438	<b>GROUP ART UNIT</b> 2814	<b>ATTORNEY DOCKET NO.</b> 241014US2S DIV	
<b>APPLICANTS</b> Koichi Kokubun, Yokohama-shi, JAPAN; <b>** CONTINUING DATA *****</b> This application is a DIV of 10/178,749 06/25/2002 PAT 6,635,915 <b>** FOREIGN APPLICATIONS *****</b> JAPAN 2001-193323 06/26/2001 <b>IF REQUIRED, FOREIGN FILING LICENSE GRANTED</b> <b>** 02/25/2004</b>					
Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Allowance Verified and Acknowledged Examiner's Signature _____ Initials _____		<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 4	<b>TOTAL CLAIMS</b> 12	<b>INDEPENDENT CLAIMS</b> 2
<b>ADDRESS</b> 22850					
<b>TITLE</b> METHOD OF MANUFACTURING THE SEMICONDUCTOR DEVICE HAVING A CAPACITOR FORMED IN SOI SUBSTRATE					
<b>FILING FEE RECEIVED</b> 1050	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		